

Complete if Known

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

SHEET

1

OF

1

Application Number

10/749,256

Filing Date

12/31/2003

Applicant(s)

Udeshi et al.

Art Unit

2175

Examiner Name

Unknown

Attorney Docket Number

34003.100

U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

NON-PATENT LITERATURE DOCUMENTS

NON-PATENT LITERATURE DOCUMENTS		
Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume-issue number(s), publisher, city/country where published
HR	AA	Co et al., "Iso-Splatting: A Point Based Alternative to Isosurface Visualization", Proceedings of the 11 th Pacific Conference on Computer Graphics and Applications (PG'03), IEEE 2003.
	AB	International Search Report from PCT Application Number PCT/US2004/043833, May 2005.
HR	AC	Rusinkiewicz et al., "Qsplat: A Multiresolution Point Rendering System for Large Meshes", Computer Graphics Proceedings, Annual Conference Series 2000, pp. 343-352.
HR	AD	Written Opinion of the International Searching Authority from PCT Application Number PCT/US2004/043833, May 2005.

**Examiner
Signature**

Date
Considered

6/23/06

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

OTHER PRIOR ART		
Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume-issue number(s), publisher, city/country where published
HRR	AA	E. PARKER, et al., "EXPLOITING SELF-SIMILARITY IN GEOMETRY FOR VOXEL BASED SOLID MODELING", Eight ACM Symposium on Solid Modeling and Applications SM'03, June 16-20, 2003, Seattle, Washington
I	AB	E. PARKER, et al., "MEMULATOR: A FAST AND ACCURATE GEOMETRIC MODELING, VISUALIZATION AND MESH GENERATION FOR 3D MEMS DESIGN AND SIMULATION", Nonotech 2003 Volume 2, Technical Proceedings of the 2003 Nanotechnology Conference and Trade Show.
I	AC	T. UDESHI, "TETRAHEDRAL MESH GENERATION FROM SEGMENTED VOXEL DATA", 12 th International Meshing Roundtable, September 14-17, 2003
HRR		
HRR		

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In place of PTO-1449 Form				U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number		10/749,256	
				Filing Date		12/31/2003	
				Applicant(s)		Udeshi et al.	
				Art Unit		=2175-2163	
				Examiner Name		Unknown H. ROSE	
SHEET 1 OF 1				Attorney Docket Number		34003.100	

[illegible][illegible]

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HRR	AB	Hinze, "Memo Functions, Polytypically!", Institut fur Informatik III, University Bonn, Bonn Germany, July 2000.
↓	AC	Tiankai et al., "The Etree Library: A System for Manipulating Large Octrees on Disk", School of Computer Science, Pittsburgh, PA July 2003.
↓	AD	Popinet, "Gerris: a Tree-Based Adaptive-Solver for the Incompressible Euler Equations in Complex Geometries", Journal of Computational Physics Academic Press USA, Vol. 190, No. 2, September 2003.
↓	AE	International Search Report from PCT Application Number PCT/US2004/035625, March 2005.
HRR	AF	Written Opinion of the International Searching Authority from PCT Application Number PCT/US2004/035625, March 2005.

Examiner Signature	<i>[Signature]</i>	Date Considered	6/23/06
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